Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination
10/657,360	WEN, MICHAEL Y.
Examiner	Art Unit
John C. Douglas	1764

SEARCHED					
·Class	Subclass	Date	Examiner		
208	14	8/28/2007	JCD		
208	106	8/28/2007	JCD		
208	107	8/28/2007	JCD		
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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SEARCH NO (INCLUDING SEARCH		)
	DATE	EXMR
See Search History from EAST	8/28/2007	JCD